Notice of References Cited Application/Control No. 10/573,630 Applicant(s)/Patent Under Reexamination OHISHI ET AL. Examiner Dung V. Nguyen Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	А	US-			
	В	US-		·	
	С	US-			
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	G	US-			
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	1	US-			
	J	US-			
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	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2004-183208	07-2004	Japan	Koike et al	B24C 1/00
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	Р					
	Q			-		
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NON-PATENT DOCUMENTS

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